

**AMENDMENTS**

**IN THE SPECIFICATION:**

*Please replace the paragraph in the Related Applications section with the paragraph on the following page:*

**RELATED APPLICATIONS**

This application is related to U.S. Application Serial No. 10/642,939, filed on August 18, 2003, attorney docket No. 03-IMP-056, entitled, "MEMS Based Multi-Polar Electrostatic Chuck" which is incorporated herein by reference, and U.S. Application Serial No. 10/661,180, filed on September 12, 2003, attorney docket No. 03-IMP-002, entitled, "Clamping and De-clamping Semiconductor Wafers on a J-R Electrostatic Chuck Having a Micromachined Surface by Using Force Delay in Applying a Single-Phase Square Wave AC Clamping Voltage".